

The 2nd KVS-AVS Joint Symposium

Date: 2012. Aug 21

Time		Speaker	Affiliation	Title
10:00-10:10	Opening remark	Chong-Yun Park	Sungkyunkwan University	-
10:10-10:50	Talk 1	Susan B. Sinnott	University of Florida	Atomic-Scale Insights into Material Properties and Design
10:50-11:30	Talk 2	Myoung-Woon Moon	Korea Institute of Science and Technology (KIST)	Nano-structures on polymers evolved by ion beam/plasma
11:30-12:10	Talk 3	Jung-Sik Yoon	National Fusion Research Institute (NFRI)	Plasma Chemistry Data Research for Plasma Applications
12:10-13:00	KVS-AVS Business Meeting			
14:20-15:00	Talk 4	Richard van de Sanden	Dutch Institute for Fundamental Energy Research (DIFFER)	Expanding thermal plasma CVD of silicon thin films and nano-crystals: fundamental studies and applications
15:00-15:40	Talk 5	Seong-In Kim	Cheorwon Plasma Research Institute (CPRI)	Plasma Engineering for Nano-Materials
15:40-16:20	Talk 6	Yeon-Ho Im	Chonbuk National University	GPU based feature profile simulation for deep contact hole etching in fluorocarbon plasma